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Bib Data Sheet

SERIAL NUMBER	FILING OR 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
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APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP04/08090 06/03/2004

**** FOREIGN APPLICATIONS *******

JAPAN 2003-170584 06/16/2003

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN		12	3
Verified and Acknowledged	Examiner's Signature _____ Initials _____				

ADDRESS

21553

TITLE

Method for processing nitride semiconductor crystal surface and nitride semiconductor crystal obtained by such method

FILING FEE RECEIVED 900	<p>FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:</p> <ul style="list-style-type: none"> <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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